Electronic Acknowledgement Receipt					
EFS ID:	7112946				
Application Number:	10808499				
International Application Number:					
Confirmation Number:	5721				
Title of Invention:	Method for testing semiconductor film, semiconductor device and manufacturing method thereof				
First Named Inventor/Applicant Name:	Hidekazu Miyairi				
Customer Number:	31780				
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Payment was successfully received in RAM	\$180
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Document Number	Document Description	File Name	File Size(Bytes)/ Message Digest	Multi Part /.zip	Pages (if appl.)
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Information:					
Warnings:			1		
	Information Disclosure Statement (IDS) Filed (SB/08)		3	3	
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6		IDS_03_01_2010.pdf	5fd08069d62426a6031efbeda4ccea4fc463 83a8	yes	3
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1	Foreign Reference		1433673	no	9

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